



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Donald L. Yates

Serial No.: 10/027,951

Filed: December 19, 2001

For: METHOD OF REDUCING WATER SPOTTING AND OXIDE GROWTH ON A SEMICONDUCTOR STRUCTURE

Confirmation No.: 2633

Examiner: A. Markoff

Group Art Unit: 1746

Attorney Docket No.: 2269-3375.6US
(95-0999.5)

Notice of Allowance Mailed:

August 30, 2004

Express Mail Mailing Label No.: EL 994827835 US
Date of Deposit with USPS: November 30, 2004
Person making Deposit: Steve Wong

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 10 of this paper.

Remarks begin on page 16 of this paper.